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| Notice of References Cited | Application/Control No. 10/526,786 | Applicant(s)/Patent Under Reexamination YAMOTO, HISAYOSHI | |
| | Examiner Richard Bueker | Art Unit 1763 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-----------------------|----------------|
| * | A | US-6,098,964 | 08-2000 | Schmitt, John V. | 261/75 |
| * | B | US-6,258,171 | 07-2001 | Agarwal, Vishnu Kumar | 118/715 |
| * | C | US-6,540,840 | 04-2003 | Toda et al. | 118/726 |
| * | D | US-2002/0192375 | 12-2002 | Sun et al. | 427/255.28 |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | JP 2000-216150 | 08-2000 | Japan | Toda | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

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